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Chemical analysis of raw materials and refractory products containing silicon-carbide, silicon-nitride, silicon-oxynitride and sialon-_—

Part 2:

Determination of volatile components, total carbon, free carbon, silicon carbide, total and free silicon, free and surface silica

Analyse chimique des matières premières et des produits réfractaires contenant du carbure de silicium, <u>du</u> nitrure de silicium, <u>oxynitrure</u> de silicium et <u>sialon du SiAlON</u> —

Partie 2: <u>Détermination Dosage</u> des <u>composants composés</u> volatils, du carbone total, du carbone libre, du carbure de silicium, <u>du</u> silicium <u>totaletotal</u> et libre et de la silice libre et <u>superficiel</u> <u>superficielle</u>

<u>FDIS stage</u>

ISO/DISFDIS 21068-2:2023(E2024(en))

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO document should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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This document was prepared by Technical Committee ISO/TC 33, *Refractories*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 187, *Refractory products and materials*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 21068-2:2008), which has been editorially and technically revised.

The main changes are as follows:

- The methods described in ISO 12698-1:2007 for the determination of free carbon, silicon carbide and free silica were inserted intohave been included in this document;
- Methodsmethods that are no longer used in practice have been removed;
 - The list of documents in Normative References has been adjusted;
 - Bibliography was adjusted to this document;
- The entire-normative references and bibliography have been updated;
- __document has been comprehensivelyeditorially revised with respect to.

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Introduction

The ISO 21068 series has been developed from the combination of EN 12698-1:2007-[1] and EN 12698-2:2007-[2] and ISO 21068-1:2008-[3] ISO 21068-2:2008-[4] and ISO 21068-3:2008-[5] The latter has been originally developed from the combination of Japanese standard JIS R 2011:2007-[6] and work items developed within CEN. Because there is a wide variety of laboratory equipment in use, the most commonly used methods are described.

ISO 21068-4 is derived from EN 12698-2:2007-[2] describing XRD methods for the determination of mineralogical phases typically apparent in nitride and oxy-nitride bonded silicon carbide refractory products using a Bragg-Brentano diffractometer.

The ISO 21068 series is applicable to the analysis of all refractory products as classified in the ISO 10081- 1^{-120} ISO 10081- 2^{-120} ISO 21068 series covers the full range of analysis from pure silicon carbide to oxide refractory composition with low-content silicon carbide and/or nitrides. Primarily, the ISO 21068 series provides methods to distinguish between different carbon bound types like total carbon (C_{total}) and free carbon (C_{free}) and derives from these two the silicon carbide content. ISO 21068-4 includes details of sample preparation and general principles for qualitative and quantitative analysis of mineralogical phase composition. Quantitative determination of α -Si₃N₄, β -Si₃N₄, Si₂ON₂, AlN, and sialon are described.

If free carbon is present, ISO 21068-2 includes different temperature treatments to determine the mass changes gravimetrically. Frequently, the resulting residue is used for other determinations.

The determination of other groups of analytes described in the ISO 21068 series are free metals, free silicon (Si_{free}), free aluminium (Al_{free}), free magnesium (Mg_{free}), free iron (Fe_{free}) and the group of oxides from main to trace components.

The ISO 21068 series also describes the determination of silicon dioxide, total silicon, oxygen and nitrogen and other oxide bound metals that typically occur in the materials.

It represents a listing of analytical methods which is generally structured according to material composition. However, it is still the user who should prove the applicability of the method depending on the material and analytical requirements.

The most broadly used analytical techniques such as X-ray fluorescence spectroscopy (XRF) and inductively coupled plasma-optical emission spectrometry (ICP-OES) suffer from the disadvantage that the analytical results are chemical species independent. For carbon-containing ceramic raw materials and compositions, the ISO 21068 series provides analytical methods for the determination of free carbon, and SiC in the presence of oxide compounds in particular SiO_2 .

Due to the diversity of laboratory equipment, the ISO 21068 series summarizes broadly used analytical techniques which lead to equivalent results. For example, the determination of carbon is based on all described methods on the reaction of carbon with oxygen at elevated temperatures to CO_2 . Thus, carbon is analysed as CO_2 .

As well as carbon and carbide compounds, metallic silicon, aluminium and magnesium are considered. While metallic silicon is mainly a precursor material which remains after the production process of SiC in the raw material, metallic aluminium is added as an antioxidant in carbon-containing refractory formulations.

Mostly oxide bound components, such as Al_2O_3 , CaO, MgO, TiO_2 , Cr_2O_3 , ZrO_2 and alkalis, can be determined by XRF, ICP-OES or wet chemical methods (see ISO 12677, ISO 26845, ISO 21587-1, ISO 21587-2 and ISO

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21587-3). These results can be corrected by formulae provided by the ISO 21068 series, in consideration of the values obtained by the determination of carbon, SiC, and metallic components.

The ISO 21068 series also provides methods for qualitative and quantitative determinations of the nitrogen content and the determination of oxygen. Thereby only the total content of nitrogen and oxygen is given; a precise determination of non-carbide components (oxides and nitrides) is not possible in this way.

The ISO 21068 series also provides methods to distinguish quantitatively between different varieties of nitrides like silicon nitride, silicon oxy-nitride and sialon.

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Chemical analysis of raw materials and refractory products containing silicon-carbide, silicon-nitride, silicon-oxynitride and sialon—Part 2:

Determination of volatile components, total carbon, free carbon, silicon carbide, total and free silicon, free and surface silica

<u>Chemical analysis of raw materials and refractory products containing silicon-carbide, silicon-nitride, silicon-oxynitride and sialon —</u>

Part 2:

<u>Determination of volatile components, total carbon, free carbon, silicon carbide, total and free silicon, free and surface silica</u>

1 Scope

This document specifies analytical techniques for the determination of volatile components by thermal treatment at specified temperatures, and methods for the determination of the total carbon content, free carbon, silicon carbide, total and free silicon and free and surface silica content of silicon-carbide, siliconnitride and silicon-oxynitride containing raw materials and refractory products.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO 3310-_1, Test sieves — Technical requirements and testing — Part 1: Test sieves of metal wire cloth

ISO 9286:2021, Abrasive grains and crude — Chemical analysis of silicon carbide

ISO 12677, Chemical analysis of refractory products by X-ray fluorescence (XRF) — Fused cast-bead method

ISO 20565-1, Chemical analysis of chrome-bearing refractory products and chrome-bearing raw materials (alternative to the X-ray fluorescence method) — Part 1: Apparatus, reagents, dissolution and determination of gravimetric silica

ISO 20565-2, Chemical analysis of chrome-bearing refractory products and chrome-bearing raw materials (alternative to the X-ray fluorescence method)— Part 2: Wet chemical analysis

ISO 20565-3, Chemical analysis of chrome-bearing refractory products and chrome-bearing raw materials (alternative to the X-ray fluorescence method) — Part 3: Flame atomic absorption spectrometry (FAAS) and inductively coupled plasma atomic emission spectrometry (ICP-AES)

ISO 21068-<u>-</u>1, Chemical analysis of raw materials and refractory products containing silicon-carbide, silicon-nitride, silicon-oxynitride and sialon — Part 1: General information, terminology and sample preparation

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ISO 21079-1, Chemical analysis of refractories containing alumina, zirconia and silica — Refractories containing 5 percent to 45 percent of ZrO₂ (alternative to the X-ray fluorescence method) — Part 1: Apparatus, reagents and dissolution

ISO 21079-2, Chemical analysis of refractories containing alumina, zirconia, and silica Refractories containing 5 percent to 45 percent of ZrO₂ (alternative to the X-ray fluorescence method) Part 2: Wet chemical analysis

ISO 21079-3, Chemical analysis of refractories containing alumina, zirconia, and silica— Refractories containing 5 percent to 45 percent of ZrO₂ (alternative to the X-ray fluorescence method)— Part 3: Flame atomic absorption spectrophotometry (FAAS) and inductively coupled plasma emission spectrometry (ICP-AES)

ISO 21587-1, Chemical analysis of aluminosilicate refractory products (alternative to the X-ray fluorescence method) — Part 1: Apparatus, reagents, dissolution and gravimetric silica

ISO 21587-2, Chemical analysis of aluminosilicate refractory products (alternative to the X-ray fluorescence method) — Part 2: Wet chemical analysis

ISO 21587-3, Chemical analysis of aluminosilicate refractory products (alternative to the X-ray fluorescence method) — Part 3: Inductively coupled plasma and atomic absorption spectrometry methods

ISO 26845, Chemical analysis of refractories — General requirements for wet chemical analysis, atomic absorption spectrometry (AAS) and inductively coupled plasma atomic emission spectrometry (ICP-AES) methods

3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO 21068-1 apply.

ISO and IEC maintain terminology databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at https://www.iso.org/obp
- IEC Electropedia: available at https://www.electropedia.org/

4 Determination of volatile components by gravimetric methods

4.1 General

The determination of volatile components is defined as change in mass caused by heat treatment of the sample at a defined temperature. The change in mass is measured by weighing.

 $\frac{\text{Table 1}}{\text{Table 1}}$ gives an overview of methods for determination of volatile components.

Table 1 — Methods for determination of volatile components

Title of method	Temperature	Subclaus e	Application
Loss on drying (LOD ₂₅₀ WLOD ₂₅₀)	250 °C	4 <u>.2</u> 4.2	Attached water and chemically combined water are removed, for example, in clay containing plastic formulations.
Loss on ignition in argon (LOI _{ArWLOIAr})	750 °C	4.3 <u>4.3</u>	All volatile compounds from pitch- or resin-bonded formulations are removed.

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4.34.2 Determination of the loss on drying at 250 °C (LOD250WLOD250)

4.3.14.2.1 **Principle**

The test sample is heated at 250 °C ± 10 °C and the change in mass is determined gravimetrically.

4.3.24.2.2 **Apparatus**

4.2.2.1 Heat-resistant container, for example, with dimensions 200 mm × 150 mm × 30 mm and made from stainless steel.

4.2.2.2 Analytical balance, capable of measuring to the nearest 0,01-g.

4.3.34.2.3 **Procedure**

Heat the heat-resistant container at 250 °C \pm 10 °C for 30 min. Cool in a desiccator, weigh and record its empty mass, m_0 , to the nearest 0,01 g.

Transfer 100 g to 600 g of the sample into the container and spread it out evenly. Then weigh and record the mass, m_1 , of the container and sample to the nearest 0,01 g.

Place the container without a lid in air and heat it at 250 °C \pm 10 °C for 16 h. Allow to cool in a desiccator. Weigh and record the mass, m_2 , of the container plus the dried sample to the nearest 0,01 g.

4.3.44.2.4 Calculation

Calculate the loss on drying at 250 °C, w_{LOD250} , as a percentage by mass, using Formula (1). Formula (1).

$$w_{\text{LOD250}} = \frac{m_1 - m_2}{m_1 - m_0} \times 100$$
 (1)

$$w_{\text{L0D250}} = \frac{m_1 - m_2}{m_1 - m_0} \times 100$$
 ISO/FDIS 21068-2 (1)

where

 w_{LOD250} is the loss on drying at 250- $^{\circ}$ C, in mass percent;

 m_0 is the mass of the empty container, in grams;

 m_1 is the mass of the container plus the sample before heating, in grams;

 m_2 is the mass of the container plus the sample after heating, in grams.

4.44.3 Determination of the loss on ignition in argon (LOI ArWLOIAr)

4.4.14.3.1 **Principle**

The sample is heated in an argon atmosphere at 750 °C to remove volatile matter. The change in mass is determined gravimetrically.

NOTE The residue can be used for determination of Ctotal, SiC and Cfree in organic matter containing materials.

The change in mass during heating in argon must be considered for the calculation of Ctotal, SiC and Cfree.

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4.4.24.3.2 **Apparatus**

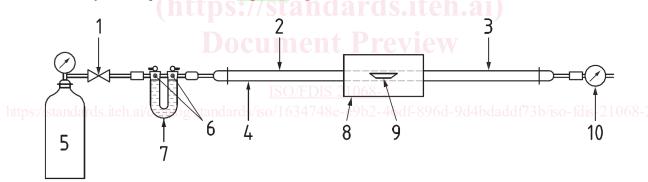
Ordinary laboratory apparatus and the following.

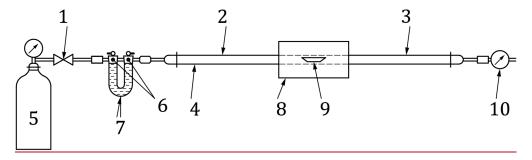
- **4.3.2.1 Analytical balance**, capable of measuring to the nearest 0,001-g.
- **4.3.2.2 U-tube**, with ground stoppers and filled with magnesium perchlorate.
- **4.3.2.3 Resistance furnace**, capable of reaching (750 ± 25) °C, in the centre of the heating zone.
- **4.3.2.4 Thermocouple with display**, registering up to 1 200 °C.
- **4.3.2.5 Ceramic tube**, with cones or other gastight connector, of suitable diameter, made from porcelain, sillimanite, quartz or other suitable material.
- **4.3.2.6 Open combustion boats**, of unglazed ceramic material, the length of which matches the oven's zone of constant temperature. The boats shall be broad enough to accommodate the amount of sample required for the determination.
- **4.3.2.7 Gas flowmeter**, with an upper scale reading of around 20 l/h.

The argon-conducting parts, such as tubes and connections, must be made of material proofed against oxygen diffusion. Preferable materials are glass and copper. Silicone is unsuitable.

4.4.34.3.3 **Test assembly**

The test assembly is set up as shown in Figure 1. Figure 1.





Key

- 1 valve for pressure control
- 2 cold zone B
- 3 cold zone A
- 4 ceramic tube

- 5 argon cylinder
- 6 glass wool
- 7 magnesium perchlorate
- 8 resistance furnace

- 9 combustion boat
- 10 gas flowmeter
- _ _
- _ _